High capacitance carbon-based xerogel film produced without critical drying

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We report the production of carbon-based xerogel film without the need for supercritical drying. Xerogel samples were characterized with field emission scanning electron microscopy, nitrogen adsorption/desorption at 77 K, Raman spectroscopy, thermogravimetric analysis, and electrical conductivity and cyclic voltammetry measurements. Experimental results reveal that the film is largely crack free and homogeneous in thickness, and, importantly, has high surface area, large nanopore volume, and an excellent performance for electrical charge storage—both per unit mass and unit volume. These results indicate that the film has potential applications for electrical energy storage devices. © 2008 American Institute of Physics. [DOI: 10.1063/1.2976684]

Nanoporous carbon films have been of great interest for many years because of their potential use in separation and purification, catalysis, and chromatographic separation and for such applications as electric double-layer capacitors, bio-catalytic sensors, and microscopes.^{1–7} Although numerous methods such as chemical vapor deposition, hydrothermal decomposition of carbide compounds, and polymer coating and pyrolysis have been developed for the fabrication of carbon film,^{8–10} easily scalable self-supported nanoporous carbon films have not yet been obtained with any of them. The following promising methods for fabricating the pore structure of carbon film have recently been reported: colloidal silica imprinting, microbead patterning, and presynthesized mesoporous silica scaffolding.¹¹⁻¹⁴ However, these methods are tedious and prone to surfactant cost, incomplete infiltration of carbon precursors, formation of nonporous carbon on the external surface of the mesoporous powders, massive loss of carbon in the form of volatile carbon-containing species during pyrolysis, and difficulty in controlling the macroscopic morphology.^{15,16} Moreover, these methods are extremely difficult to apply to the fabrication of large-scale uniform nanoporous films.¹⁵ Although efforts have been made recently to synthesize nanoporous carbon by direct pathways of nanocasting¹⁷ and to prepare ordered porous carbon film through self-assembly of block copolymers,¹⁵ a scalable method for preparing nanoporous carbon films has not yet been established.

Since the pioneering demonstration of Kistler¹⁸ of the pore continuity of aerogels, much attention has been directed at the sol-gel process followed by supercritical drying for fabricating porous materials.¹⁸ Pekala and co-workers^{19,20} succeeded in preparing carbon aerogel, which is carbonized resorcinol-formaldehyde aerogel pyrolyzed in an inert atmosphere such as nitrogen. Due to their large surface area and easily tunable nanoporosities, such materials have received considerable attention in the study of the fundamentals of materials science and for commercial application to hydrogen fuel storage, catalysis, and chromatographic separation

and for use in supercapacitors, gas diffusion electrodes in proton exchange membrane fuel cells, and anodes in rechargeable lithium ion batteries.^{21–23} Unfortunately, the supercritical drying required to prevent collapse of the highly nanoporous aerogel is expensive although supercritical processes can be used on a large commercial scale. In this letter we report a supercritical drying-free method for preparing uniformly thin carbon xerogel film (CXF). The prepared CXF exhibited excellent electrical charge storage.

The CXF was synthesized using the slit-space film model and resorcinol $[C_6H_4(OH)]_2$ (min. 99.0%), formaldehyde solution (HCHO) (36.0%-38.0%), sodium carbonate (Na₂CO₃) (min. 99.5%), and ion-exchanged water as sources, of which the molar ratio was 1:2:0.025:0.4. All agents were used as received from Wako Pure Chemical Industries, Ltd. without further purification. The polycondensation and polymerization of resorcinol with formaldehyde was performed for 1 day at room temperature, afterward for 1 day at 323 K, and successively for 3 days at 363 K. After the reaction cell was opened, the resorcinol-formaldehyde polymer xerogel film was dried in air at 298 K and 101.3 $\times 10^3$ Pa. The dried film was pyrolyzed at 1323 K in a nitrogen atmosphere. A shiny black and slightly flexible CXF was obtained. Field emission scanning electron micrographs (FE-SEMs) of the samples were obtained using a scanning electron microscope (JEOL, JSM-633F) operated at an accelerating voltage of 5.0 kV. The nitrogen adsorption/desorption isotherms were measured at 77 K using a gas adsorption analyzer (Quantachrome, Autosorb-1). The samples were evacuated at 10⁻⁴ Pa and 383 K for 2 h prior to the adsorption measurement. The Raman spectra were obtained with a laser Raman spectrometer (JASCO, NRS-1000) controlled by computer. Sample excitation was done with the 532 nm line of a Spectra-Physics LD laser. The scattered light was detected with a LN/CCD-576E GaAs photomultiplier tube. Thermogravimetric analysis (TGA) of the samples was performed using a thermal analyzer (Seiko Instruments, TG/ DTA 6200) up to 1273 K at a heating rate of 1 K min⁻¹ in a mixed flow of oxygen and nitrogen at 200 ml min⁻¹. The cyclic voltammetry measurement was performed within the potential range from 0 to 0.8 V using a 2.0M H₂SO₄ aqueous

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FIG. 1. High- and low-magnification (inset) FE-SEM of CXF.

solution as electrolyte and Ag/AgCl as a reference electrode. The potential scan rate was fixed at 10 mV s⁻¹. The directcurrent volume electrical conductivity was measured using a potentiostat/galvanostat (Hokuto Denko, HA-501G) at room temperature.

The high- and low-magnification FE-SEM images of the sample in Fig. 1 show that the sample had relatively uniform pore sizes with a highly disordered pore structure. Mesopores ~ 10 nm in width are evident. The CXF was homogeneous with a thickness of several micrometers. It can be fabricated in sizes up to several square centimeters without cracks, as shown by the low-magnification image.

Low-temperature nitrogen adsorption measurement is a common means for evaluating the pore structure of a solid. The adsorption and desorption isotherms of nitrogen on the CXF at 77 K, plotted in Fig. 2, rose steeply below P/P_0 =0.02, and there was a hysteresis loop extending from $P/P_0=0.70$ to 0.90, suggesting the coexistence of micropores and mesopores in the film. There were type IV isotherms and a clear H1 hysteresis loop, suggesting that the mesopores were quite uniform. The micropore and mesopore size distributions (Fig. 2, inset), respectively, determined by the Horváth and Kawazoe method and the Barrett-Joyner-Halenda method, were narrow.. The average pore sizes were 0.6 and 9 nm, respectively. This mesopore size is consistent with previously estimated ones from FE-SEM observations. Subtracting pore effect analysis²⁴ of the N₂ adsorption isotherm showed that the surface area was 915 m² g⁻¹, the micropore volume was $0.37 \text{ cm}^3 \text{ g}^{-1}$, and the mesopore volume was $0.73 \text{ cm}^3 \text{ g}^{-1}$. This high porosity and the bimodal pore size distribution are distinct advantages for carbon film in terms of capacitance storage because the nanopores (we refer nanopores to micropores and mesopores for convenience²³)



FIG. 2. Nitrogen adsorption (\bigcirc) / desorption (\bigcirc) isotherms at 77 K on CXF. Insets show the micropore and mesopore size distributions.



FIG. 3. Cyclic voltammetry graphs of CXF in $2.0M\ H_2SO_4$ solution at scan rate of 10 $\ mV\ s^{-1}.$

ensure high-capacity storage, and the interconnected mesopore channels provide fast mass transfer.

The electrochemical behavior of the CXF was characterized by means of the electrical conductivity and cyclic voltammetry measurements. The CXF had a direct-current volume electrical conductivity of 3.5×10^3 S m⁻¹ at room temperature. The cyclic voltammogram of CXF in 2M $H_2SO_{4(aq)}$ electrolyte solution at a scan rate of 10 mV s⁻¹ was very close to an ideal rectangular shape (Fig. 3), suggesting that energy is retrievable in the discharge over the same potential range as that required to store the energy on charging. The CXF showed a rapid current response on voltage reversal at each end potential. Its appearance density was 0.91 g cm^{-3} , much higher than that of ordinary activated carbons. It is noteworthy that the CXF had both a high massspecific capacitance and a volume-specific capacitanceboth of which are required for practical application. Carbon xerogels can be activated with gases such as air, steam, and CO_2 to greatly increase the surface area and to modify their surface.^{23,24,26} This means that the capacitance characteristics of CXF can be further improved, which is a future research topic.

The CXF was further characterized by Raman spectroscopy and TGA to investigate its chemical structure. The Raman spectrum [Fig. 4(a)] had two distinct peaks, at 1350 and 1580 cm⁻¹ shifts, which were, respectively, assigned to disordered and ordered carbon phases. From the Raman spectrum, the in-plane microcrystallite size was determined using a method reported elsewhere¹⁹ to be 2.4 nm. The TG/ derivative thermalgravimetry (DTG) data showed that the CXF decomposed at 773 K in a mixed flow of oxygen and nitrogen [Fig. 4(b)]. The Raman and TG analysis revealed that the CXF had a chemical structure remarkably similar to that of carbon aerogels synthesized using the standard CO₂ supercritical drying process.^{19,20,26} In short, the film was chemically, thermally, and mechanically stable.



FIG. 4. (a) Raman spectrum of CXF, and (b) TG (solid line), and DTG (dotted line) curves of CXF in a mixed flow of oxygen and nitrogen.

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In conclusion, we showed that uniformly thin carbonbased xerogel film with bimodal micropores and mesopores can be directly fabricated under ambient conditions using a thin reaction space without supercritical drying. The carbon film has a large surface area and well-developed nanoporosity and pore interconnectivity, making it well suited for highcapacitance storage. Its simple and economic preparation should lead to the use of conductive CXF in many electrochemical applications such as gas sensors, biological sensors, and supercapacitors.

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